



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kie Y. Yohn et al.

Title: ATOMIC LAYER-DEPOSITED LaAlO₃ FILMS FOR GATE DIELECTRICS

Docket No.: 1303.050US2

Serial No.: 10/789,042

Filed: February 27, 2004

Due Date: December 29, 2005

Examiner: Allan R. Wilson

Group Art Unit: 2815

MS Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

☒ Return postcard.

☒ Preliminary Amendment and Response To Restriction Requirement (12 pgs.).

If not provided for in a separate paper filed herewith, Please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number 21186

By: David R. Cochran

Atty: David R. Cochran

Reg. No. 46,632

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 29 day of December, 2005.

Name

KATE GANDON

Signature

Kate G

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

(GENERAL)



Serial No. 10/789,042

PATENT

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Title: ATOMIC LAYER-DEPOSITED LaAlO₃ FILMS (as amended)

PRELIMINARY AMENDMENT AND RESPONSE TO RESTRICTION
REQUIREMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Applicant submits the following.